## Atomic Resolution Defect Analysis Using Low Angle ADF-STEM

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High-resolution scanning transmission electron microscopy (STEM) has recently been one of the most important techniques in advancing the analysis of crystalline materials. Traditionally, high-resolution STEM is performed in the Z-contrast mode, wherein the annular dark-field (ADF) detector is situated such that only high-angle scattering is accepted. It has been shown that under these conditions, the resulting intensity can be approximated using an incoherent imaging model [1]. Because the low-angle Bragg scattering is not collected by the ADF, the resulting contrast is generally directly interpretable, and does not suffer some of the drawbacks of phase-contrast high-resolution TEM, such as strong dependencies on defocus and thickness [2].

Much of the initial work on Z-contrast STEM was rather ambiguous in defining the "high angle" necessary for incoherent imaging to apply, yet other calculations yielded an inner detector angle so large that the resulting signal would be very weak [1-3]. However, when using a more modest scattering angle as in low angle annular dark-field (LAADF), while still in a zone-axis configuration, enhanced contrast from crystalline defects results. Early work on the origin of this contrast has suggested that atoms, displaced near defects and potentially offset from perfect lattice channels, cause the electron beam to be de-channeled while penetrating the specimen [4-6].

The present contribution highlights LAADF imaging of defects, while maintaining atomic resolution. Specifically, various defects present in a Ni-based superalloy were examined using an FEI Titan  $^{3}$  80 – 300 probe-corrected monochromated S/TEM operated at 300 kV. The camera length (CL), i.e., ADF detector acceptance angle, was systematically varied to show either Z-contrast or defect contrast.

Fig. 1 illustrates the defect contrast obtained in zone-axis oriented LAADF. The left image was taken from the same area as the right, only with the ADF acceptance angle adjusted to 14 - 91 mrad (CL = 285 mm); paired dislocations exhibit bright contrast throughout the left image, highlighted with red lines. The right image was acquired with the ADF acceptance angle ranging from 69 - 422 mrad (CL = 58 mm), and is considered to be Z-contrast in nature. As shown in Fig. 2, atomic resolution LAADF images remain interpretable, despite the contribution of low-angle scattering to the image. The stacking fault present runs parallel to one set of {111} planes, with interplanar spacing 0.206 nm. When the CL is adjusted for Z-contrast (right image), note the lack of enhanced intensity over the fault, indicating that the bright contrast observed in LAADF is not a result of heavy-element segregation to the fault or any variance in chemical species. Since such heavy-element segregation can occur at planar defects, it is particularly important to accurately understand the LAADF contrast, in order to distinguish it from Z-contrast.

Additionally, high-resolution images were acquired in defect-free regions of the crystal. Within the given range of ADF detector acceptance angles, variations on defocus again produced atomically resolved images, free of contrast reversals. Experimental evidence has also indicated that a given defect or strain field need not be perfectly aligned along a low-index zone for observation, a requirement that can complicate traditional HAADF imaging. STEM simulations of both perfect and faulted crystals are in progress and will be discussed in addition to experimental results.

## References

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Figure 1: Two images of the same area with the foil tilted to the [011] zone; the left image was acquired at a CL of 285 mm (LAADF) and defect contrast is visible; when the CL is decreased to 58 mm (HAADF), Z-contrast results, as in the right image.



Figure 2: Enhanced contrast from a stacking fault visible in [011] LAADF conditions, CL = 285 mm (left); the right image, acquired at CL = 58 mm, eliminates the possibility that the enhanced contrast observed is due to heavy-element segregation to the defect.